

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wayne Chen et al.
Assignee: KLA-Tencor Corporation
Title: System and Methods for Classifying Anomalies of Sample Surfaces
Application No.: 10/613,634 Filing Date: July 3, 2003
Examiner: Michael Patrick Stafira Group Art Unit: 2877
Docket No.: TNCR.178US1 Conf. No.: 4612

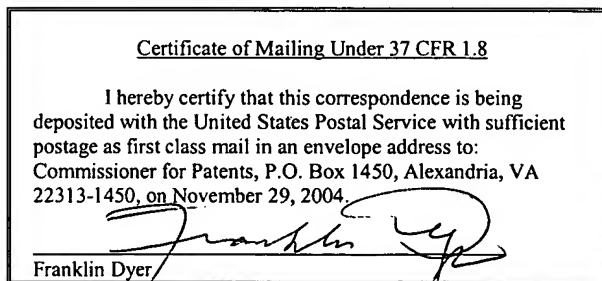
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME


Dear Sir:

Applicant(s) respectfully petition(s) for a one-month extension of time within which to respond to the outstanding Office Action mailed July 28, 2004, such extension allowing the undersigned until November 29, 2004 to respond, November 28 being a Sunday.

A check is enclosed that includes the amount of \$110.00, as set forth in the enclosed transmittal letter.



Respectfully submitted,


James S. Hsue
Reg. No. 29,545

11/29/04
Date